

A comprehensive study on the sputtering of the Lunar surface

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Sputtering yields Introduction • The solar wind (~96% H⁺, ~4% He²⁺) can impinge directly Rouah on the dayside of the lunar surface, releasing material via ion sputtering. • Among other processes, this is a source mechanism in the formation of the lunar exosphere, noteworthy for the supra-thermal ejecta energies. ring • Often, exosphere models rely on popular sputtering codes for input data on the sputtering contribution without

- further validation.
- We aim to constrain three physical quantities describing the sputtering process: angular distribution, sputtering yield and energy distribution.

Methods

ion beam

Quartz Crystal Microbalance (QCM) [1]

- $\frac{\Delta m}{m} = -\frac{\Delta f}{f}$ [2]
- Resolves mass changes of thin films in real time \rightarrow direct sputter yield determination
- Used sample: thin film grown from Apollo 16 #68501 Catcher QCM [3]
- Second QCM facing the samples, collecting ejecta
- ion beam • Probes angular distribution of released particles
- With calibration through the thin film \rightarrow obtain sputter yields of bulk samples indirectly
- Used sample: pressed pellet [4] from Apollo 16 #68501



- Influence of surface morphology: The increase in roughness when going from the thin film sample to the pellet decreases the sputtering yield and suppresses the dependence on the incidence angle
- This reduction is observed both in experiments and simulations [7]
- 20 40 80 60 --· SRIM 1.6+ - SDTrimSP Exp. Flat 1.2† Rough Regolith .8.0 <u>≺ie</u> 9.0 or ds 0.4 0.2 0.0 20 80 Incidence Angle α (°)
 - Red line: simulations for porous structures modelled after [8], representative for the conditions in the Lunar regolith

• SRIM (dashed): previous assumptions

Sputtering yields have been severely overestimated!

Simulations – SDTrimSP [5, 6]

- Track simulated ions and their generated recoils through a solid
- Binary Collision Approximation (BCA): assumes a series of independent collisions between two nuclei
- Most basic version assumes flat, amorphous targets
- Cannot usually correctly calculate sputtering yields *ab initio* \rightarrow experimental benchmarks important, ongoing debate on how to sensibly choose the variety of input parameters
- SDTrimSP-3D: three-dimensional variant allowing to untangle surface topography effects from intrinsic material properties





- Proposed method for measurements: Time of Flight – Secondary Neutrals Mass Spectrometry (ToF–SNMS) [9]
- Most sputtered particles neutral \rightarrow ionise using a focused laser
- Timing between ion pulse, ionisation and extraction and knowledge of distance between sample and ionisation volume gives kinetic energy of ejecta
- Time of flight difference between particles

1.0 0.8 ف 0.6 2 0.2 0.5 0.0 1.0 1.5 2.0 2.5 Energy (eV)

Ejecta energy distributions



- Mass stuck to catcher QCM as a function of polar angle β (cf. sketch above)
- Reduction in sputtered mass for grazing impact and rough samples

QCM used to compare ejecta angular distributions across sample types

- of same energy gives mass resolution
- Proof-of-principle campaign at the University of Duisburg-Essen showed feasibility, however some improvements are still necessary:
 - Better knowledge of the ionisation volume position
 - Laser capable of ionising also Si, O
- Figure above: energy distribution of Mg sputtered by Ar ions from a MgSiO₃ thin film
- "Thompsonic " behaviour (fit line) visible, even though high energetic particles not detected as efficiently

ToF–SNMS seems to be a well-suited experimental approach!

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[6] Szabo, P.S. *et al.*; NIMB **522** (2022): 47 [7] Cupak, C. *et al.*; Appl. Surf. Sci. **570** (2021): 151204 [8] Szabo, P.S. *et al.*; G. Res. Lett. **49** (2022): e2022GL101232 [9] Wucher, A. in: *ToF-SIMS: Surface Analysis by* Mass Spectrometry (2013)